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635.43483X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: S. KADLEC, et al.

Serial No.: 10/798,331

Filed: March 12, 2004

For: **METHOD FOR MANUFACTURING SPUTTER-COATED SUBSTRATES, MAGNETRON SOURCE AND SPUTTERING CHAMBER WITH SUCH SOURCE**

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97 & 1.98

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 7, 2005

Sir:

In the matter of the above-identified application, applicants are submitting herewith for the Examiner's consideration copies of documents cited in a communication from a foreign patent office in a counterpart foreign application. The documents are listed on the attached form equivalent to Form PTO-1449.

This information disclosure statement is being submitted before the mailing date of a first office action on the merits.

Each of the documents listed on the attached form equivalent to Form PTO-1449 is in the English language.

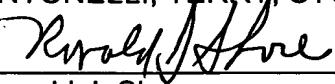
It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the

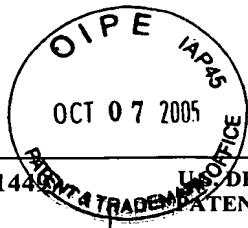
filings of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case: 635.43483X00), and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP


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Attachments



Form PTO-144 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DKT. NO. 635,43483X00	SERIAL NO. 10/798,331
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		APPLICANT	S. KADLEC, et al.
		FILING DATE	GROUP
		March 12, 2004	

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date
	AA	2004/00207 68 A1	02/05/04	Wang et al.			08/01/02
	AB	2004/00356 92 A1	02/26/04	Ding et al.			08/22/03
	AC	6,491,801 B1	12/10/02	Gung			08/07/01
	AD						
	AE						
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	AJ						
	AK						
	AL						

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation /Abstract	
							Yes	No
	AM	EP 1 067 577 A	01/10/01	Europe				
	AN	WO 2004/01735 6 A2	02/26/04	PCT				
	AO							
	AP							
	AQ							
	AR							
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	AT							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	AU	"The unbalanced magnetron: current status of development" SURFACE AND COATING TECHNOLOGY, vol. 48, no. 1, October 1, 1991 pages 81-94.
	AV	International Search Report; PCT/CH2005/000006; Filing Date: 01/06/05
	AW	
	AX	
	AY	
	AZ	
Examiner		Date Considered